

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/820,575
Filing Date April 7, 2004
Inventor..... Scott E. Moore et al.
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2886
Examiner Roy Punnoose
Attorney's Docket No. MI22-2493
Title: Semiconductor Workpiece Processing Methods and Turbidity Monitoring
Methods

RESPONSE TO OCTOBER 15, 2008 OFFICE ACTION

To: Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

From: James D. Shaurette (Tel. 509-624-4276; Fax 509-838-3424)
Wells, St. John, P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Sir:

This is a response to the Office Action dated October 15, 2008, Applicants
amend and remark as follows:

AMENDMENTS

Please enter this amendment (received on
12/15/2008) .

/Roy M. Punnoose/